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INFORMATION DISCLOSURE	Complete If Known		
STATEMENT BY APPLICANTP	Application Number	09/838493	
(Use as many sheets as necessary)	Filing Date	April 19, 2001	
	First Named Inventor	Chopra, Dinesh	
JUN 1 7 2002 B	Group Art Unit	2811 2823	
	Examiner Name	Unknown Khipm D. Nguyen	
Sheet 1 of 1	Attorney Docket No: 0		

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